

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

December 26, 2024

IGI Report Number

LG668407451

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

EMERALD CUT

Measurements

7.18 X 4.91 X 3.11 MM

GRADING RESULTS

Carat Weight

1.00 CARAT

Color Grade

H

Clarity Grade

SI 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence

NONE

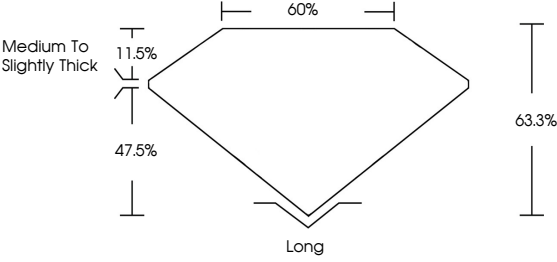
Inscription(s)

 LG668407451

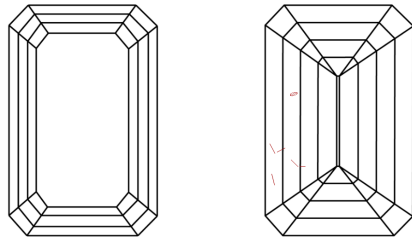
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF VS ¹⁻² VS ¹⁻² SI ¹⁻² I ¹⁻³


Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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
Symmetry

EXCELLENT

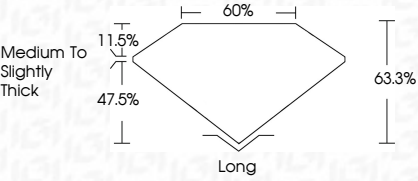
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Carat Weight

1.00 CARAT

Color Grade

H

Clarity Grade

SI 1

Depth

47.5%

Table

11.5%

Girdle

Medium to Slightly Thick

Culet

Long

Polish

EXCELLENT


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